PTO-1449			T 2		S) 80 # T	Sheet 1 of 1
INFORMATION DISCLOSURE CITATION IN AN APPLICATION (Use several sheets if necessary)			Attorney Docket No.: 0512-1251		NEW NAT	ONAL PHAS
			Applicant: Christophe CACHONCINLLE et al.			
			Filing Date: December 28, 2004		Group Art Unit:	
		U.S. PATEN	IT DOCUMENTS			
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		FOREIGN PA	TENT DOCUMENTS		<u> </u>	<u> </u>
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	OTHER DOCUM	ENTS (Including /	Author, Title, Date, Perti	nent Pages	Etc.)	
1	ROBERT ET AL: "Spectro	scopic and energe	tic investigation of capilla	ry discharge	s devoted t	o EUV
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EV A A ALA	IED.		DATE CONSIDERED			

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* English language abstract provided for the Examiner's convenience